



In Situ Cross duct TDLAS gas analyzer

PROCESS & EMISSIONS MONITORING SYSTEMS



SPECIFIC FEATURES:

- Tunable Diode Laser Spectroscopy (TDLS) technique
- In-situ and non-invasive measurement
- Large dynamic rang
- Compact and robust system
- Short response time 1s response
- High sensitivity
- Interference-free gas measurements
- Absolute measurements: no drift, no calibration required, linear response and high resolution
- Suitable for harsh environments. Unaffected by contaminants no corrosion
- No sample lines required, eliminating errors due to gas sampling
- Low maintenance and low cost of ownership

VERSIONS OF THE LAS 300XD ARE AVAILABLE TO MEET YOUR ANALYTICAL REQUIREMENTS:

- LAS 300XD NH, for ammonia (NH,) and water (H,O) monitoring
- LAS 300XD CO for low and high concentration carbon monoxide (CO) monitoring
- LAS 300XD HCI for hydrochloric acid (HCI) and water (H2O) monitoring
- LAS 300XD HF for hydrofluoric acid (HF) monitoring
- LAS 300XD O, for oxygen (O,) monitoring



including

LaserTool®

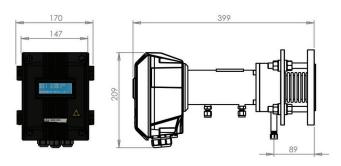
advanced software for setup and operations

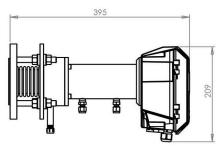
MAIN APPLICATIONS:

Process & emission monitoring for:

- > Scrubber technology
- > Combustion control
- > Chemical industry
- > Fertilizer plants
- > Waste incinerators
- > Cement industry
- > Glass industry
- > Pulp and paper
- > Biomass boilers
- > Petrochemical industry

Tunable Diode Laser Spectroscopy LAS 300XD







TECHNICAL SPECIFICATIONS

Measurement ranges:	
$\begin{array}{c} \mathrm{NH_3} + \mathrm{H_2O} \\ \mathrm{HCI} \\ \mathrm{HF} \\ \mathrm{CO} \ (\mathrm{low}) \\ \mathrm{CO} \ (\mathrm{high}) \\ \mathrm{O_2} \end{array}$	0 - 15 ppm / 0 - 500 ppm + 0 - 5% / 0 - 50% 0 - 10 ppm / 0 - 3000 ppm + 0 - 5% / 0 - 50% 0 - 100 ppm 0 - 500 ppm / 0 - 1% 0 - 1% / 0 - 100% 0 - 10% / 0 - 100%
Accuracy:	≤ ±2% of full scale
Response time (0-90%)	Typically 2-5 s
Linearity:	≤ ±1% of full scale
$\begin{array}{l} \text{Max Process gas T°C:} \\ \text{NH}_3 + \text{H}_2\text{O} / \text{HCl} + \text{H}_2\text{O} / \text{HF} \\ \text{CO (low)} / \text{CO (high)} / \text{O}_2 \end{array}$	
Max Process gas pressure	2 bar absolute
D: 1	

CO (low)/ CO (riigii)/ O ₂	+1200 C
Max Process gas pressure	2 bar absolute
Display	4x 20 alphanumeric LED backlit LCD
Input signals	Optional temperature and pressure signals inputs (4-20 mA)
Communication	Modbus RTU / Ethernet
Output signals	x2 analog outputs (4-20 mA), x2 relays
Power supply	+ 24 V DC, ripple and noise 50 mV
Power	15 W when starting-up the LAS 300 XD < 15 W in normal operation
Ambient operating T°C	-20°C to +55°C
Enclosure rating	IP65
Enclosure material	Die-cast aluminium (polyester powder coated)
Mounting flange	DN50 PN16, 2" - 150 lbs, Class 150
Mounting flange material	SS 316 L
Air purge	10-50 L/min (depends on application conditions)
Typical Stack/Duct diameter	0.5 to 20 m (depends on application conditions)

MAIN OPTIONS:

- IP55 Junction box (for power and signal)
- Purge air unit (blower, filters, flow meters, pressure regulator)
- In-line span check cell ①
- Weather protection covers
- Specific flanges
- Remote interface
- Audit cell
- Optical alignment tool ③











THE STANDARD LAS 300XD IS SUPPLIED WITH:

- Transmitter and receiver units
- 2x alignment flanges (DN50)
- 2x analog inputs/outputs
- 2x Relay contacts
- Modbus RTU RS485
- LaserTool® software







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